



ITW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TAKEI et al.

Group Art Unit: 2895

Application No.: 10/584,133

Examiner: D. NHU

Filed: October 23, 2006

Docket No.: 128515

For: COMPOSITION FOR FORMING NITRIDE COATING FILM FOR HARD MASK

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the August 21, 2009 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**